



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Tipton, et al.

Attorney Docket No.:
NOVLP075/NVLS-000820

Application No.: 10/672,311

Examiner: COLEMAN, WILLIAM D

Filed: September 26, 2003

Group: 2823

Title: METHOD OF POROGEN REMOVAL
FROM POROUS LOW-K FILMS USING
UV RADIATION

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on March 17, 2006 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed: _____

Tara Hayden

RESPONSE D

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This is submitted in response to the Office Action mailed on December 20, 2005. Please amend the above-identified application as follows:

Amendment to the claims are reflected in the Listing of Claims section, beginning on page 2 of this paper.

Remarks and arguments are in the Remarks section, beginning on page 6 of this paper.

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